



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 15, 2026

IGI Report Number

LG836636800

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED OCTAGONAL STEP CUT

Measurements

15.28 X 8.29 X 5.05 MM

GRADING RESULTS

Carat Weight

4.10 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

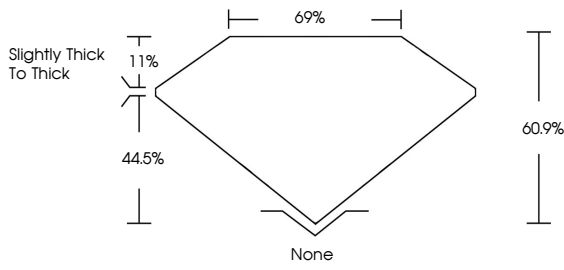
Inscription(s)

 LG836636800

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

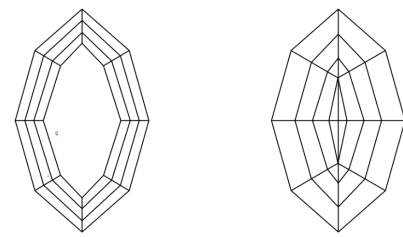
Report verification at igi.org

PROPORTIONS



Slightly Thick To Thick

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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Carat Weight

4.10 CARATS

Color Grade

E

Clarity Grade

VS 1

Depth

60.9%

Table

67%

Girdle

Slightly Thick To Thick

Culet

None

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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